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MAR 09 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Applicant Masayuki Hira, et al.

Docket Number: TI-34548

Serial No.: 10/624,814

Art Unit: 2818

Filed: 07/22/03

Examiner: Hoai V. Ho

For: Semiconductor Storage Device

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NAME OF INVENTOR(S): Masayuki Hira, et al.	
TITLE OF INVENTION: Semiconductor Storage Device	
TITLE NO.: <b>TI-34548</b>	DEPOSIT ACCT. NO.: <b>20-0668</b>
FAXED: 3-9-05 DUE: 3-9-05 ATTY/SECY: AKS/kjv	
RECEIPT DATE & SERIAL NO.: Serial No.: <b>10/624,814</b> Filing Date: 07/22/03	

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For: SEMICONDUCTOR STORAGE DEVICE

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AMENDMENT

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